PATENT APPLICATION



In re the Application of

Kazuo ICHIKAWA et al.

Group Art Unit: 1763

Application No.: 09/670,877

Examiner:

R. ZERVIGON

Filed: September 27, 2000 Docket No.: 107469

For:

CVD SUBSTRATE AND CLEANING METHOD

LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a) AND TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired December 29, 2006, an extension of time for a period of $\underline{1}$ month is hereby requested. Attached hereto is our Check No. $\underline{175879}$ in the amount of $\underline{\$120}$ in payment for:

X	Extension fee for response within first month pursuant to §1.136(a) (\$120.00)
	Extension fee for response within second month pursuant to §1.136(a) (\$450.00)
	Extension fee for response within third or subsequent month pursuant to \$1.136(a) (\$1020.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

01/31/2006 JADDO1

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Registration No. 27,075

J. Adam Neff Registration No. 41,218

JAO:JAN/slh

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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our

Deposit Account No. 15-0461